

Day : Tuesday  
 Date: 10/26/2004

Time: 10:47:09

**PALM INTRANET****Inventor Name Search Result**

Your Search was:

Last Name = JUNG

First Name = JAE

| Application# | Patent#    | Status | Date Filed | Title   | Inventor Name 51 |
|--------------|------------|--------|------------|---|------------------|
| 60467717     | Not Issued | 159    | 05/02/2003 | CHROMATOGRAPHIC ASSAY SYSTEM  | JUNG, JAEAN      |
| 60443430     | Not Issued | 159    | 01/29/2003 | CHROMATOGRAPHIC ASSAY SYSTEM  | JUNG, JAEAN      |
| 10648523     | Not Issued | 030    | 08/26/2003 | LIGHT GUIDE PLATE AND METHOD OF FABRICATING THE SAME  | JUNG, JAE-HO     |
| 10633553     | Not Issued | 041    | 08/05/2003 | FIELD EMISSION DISPLAY WITH SEPARATED UPPER ELECTRODE STRUCTURE   | JUNG, JAE-EUN    |
| 10631615     | Not Issued | 030    | 07/31/2003 | LIGHT GUIDE PLATE WITH STEPPED EDGE AND DISPLAY DEVICE HAVING THE SAME  | JUNG, JAE-HO     |
| 10629056     | Not Issued | 020    | 07/28/2003 | LAMP DRIVING APPARATUS, BACKLIGHT ASSEMBLY AND LIQUID CRYSTAL DISPLAY DEVICE USING THE SAME                             | JUNG, JAE-HO     |
| 10620414     | Not Issued | 030    | 07/17/2003 | SYSTEM FOR SIMULTANEOUSLY REMOVING DUST AND VOLATILE TOXIC ORGANIC COMPOUNDS  | JUNG, JAE-HAK    |
| 10619254     | Not Issued | 030    | 07/14/2003 | ORGANIC ANTI-REFLECTIVE COATING COMPOSITION AND METHOD FOR FORMING PHOTORESIST PATTERNS USING THE SAME                  | JUNG, JAE-CHANG  |
| 10619112     | Not Issued | 030    | 07/14/2003 | APPARATUS AND METHOD FOR PROCESSING WAFERS  | JUNG, JAE-HYUNG  |
| 10608940     | Not Issued | 160    | 06/26/2003 | METHOD OF GUIDING LIGHT, LIGHT GUIDING APPARATUS, BACK LIGHT ASSEMBLY AND LIQUID CRYSTAL DISPLAY DEVICE HAVING THE SAME | JUNG, JAE-HO     |

|                 |            |     |            |  |                 |
|-----------------|------------|-----|------------|--|-----------------|
| <u>10603012</u> | Not Issued | 071 | 06/24/2003 | PHOTORESIST OVERCOATING COMPOSITION  | JUNG, JAE CHANG |
| <u>10468468</u> | Not Issued | 030 | 02/05/2004 | METHOD FOR PREPARING HIGH QUALITY BARIUM-TITANATE BASED POWDER   | JUNG, JAE CHUL  |
| <u>10461107</u> | Not Issued | 071 | 06/13/2003 | METHOD FOR FORMING PATTERNS IN A SEMICONDUCTOR DEVICE  | JUNG, JAE-CHANG |
| <u>10454282</u> | Not Issued | 041 | 06/03/2003 | OPTICAL MEMBER, METHOD OF FABRICATING THE SAME AND LIQUID CRYSTAL DISPLAY APPARATUS HAVING THE SAME          | JUNG, JAE-HO    |
| <u>10452093</u> | Not Issued | 030 | 05/30/2003 | BACKLIGHT ASSEMBLY AND LIQUID CRYSTAL DISPLAY DEVICE USING THE SAME  | JUNG, JAE-HO    |
| <u>10436742</u> | 6811960    | 150 | 05/12/2003 | PARTIALLY CROSSLINKED POLYMER FOR BILAYER PHOTORESIST  | JUNG, JAE CHANG |
| <u>10398128</u> | Not Issued | 030 | 03/31/2003 | HIGH MANGANESE DUPLEX STAINLESS STEEL HAVING SUPERIOR HOT WORKABILITIES AND METHOD FOR MANUFACTURING THEREOF | JUNG, JAE-YOUNG |
| <u>10394606</u> | Not Issued | 071 | 03/21/2003 | NOVEL POLYMERS FOR PHOTORESIST AND PHOTORESIST COMPOSITIONS USING THE SAME                                   | JUNG, JAE CHANG |
| <u>10377352</u> | Not Issued | 041 | 02/28/2003 | BACKLIGHT ASSEMBLY AND LIQUID CRYSTAL DISPLAY APPARATUS HAVING THE SAME                                      | JUNG, JAE-HO    |
| <u>10357876</u> | Not Issued | 095 | 02/04/2003 | ORGANIC ANTI-REFLECTIVE COATING COMPOSITION AND METHOD FOR FORMING PHOTORESIST PATTERNS USING THE SAME       | JUNG, JAE-CHANG |
| <u>10353159</u> | 6762446    | 150 | 01/27/2003 | INTEGRATED CAPACITIVE DEVICE WITH HYDROGEN DEGRADABLE DIELECTRIC LAYER PROTECTED BY GETTER LAYER             | JUNG, JAE HAK   |
| <u>10174497</u> | Not Issued | 093 | 06/17/2002 | TOP-COATING COMPOSITION FOR PHOTORESIST AND PROCESS FOR FORMING FINE   | JUNG, JAE CHANG |

| PATTERN USING THE SAME |            |     |            |   |                 |
|------------------------|------------|-----|------------|---|-----------------|
| 10146277               | 6531562    | 150 | 05/14/2002 | NOVEL PHOTORESIST MONOMER, POLYMER THEREOF AND PHOTORESIST COMPOSITION CONTAINING IT  | JUNG, JAE CHANG |
| 10144336               | Not Issued | 041 | 05/13/2002 | APPARATUS AND METHOD FOR PERFORMING A MIRROR FUNCTION IN A PORTABLE TERMINAL  | JUNG, JAE-IK    |
| 10129966               | Not Issued | 161 | 05/22/2002 | MULTIPLE DRAWER-TYPE CHARNEL UNIT   | JUNG, JAE-DUK   |
| 10107659               | 6720129    | 150 | 03/27/2002 | MALEIMIDE-PHOTORESIST POLYMERS CONTAINING FLUORINE AND PHOTORESIST COMPOSITIONS COMPRISING THE SAME                                 | JUNG, JAE CHANG |
| 10107650               | 6653047    | 150 | 03/27/2002 | PHOTORESIST MONOMERS CONTAINING FLUORINE-SUBSTITUTED BENZYLCARBOXYLATE AND PHOTORESIST POLYMERS COMPRISING THE SAME                 | JUNG, JAE CHANG |
| 10107646               | 6737217    | 150 | 03/27/2002 | PHOTORESIST MONOMERS CONTAINING FLUORINE-SUBSTITUTED BENZYLCARBOXYLATE AND PHOTORESIST POLYMERS COMPRISING THE SAME                 | JUNG, JAE CHANG |
| 10099295               | 6602650    | 150 | 03/13/2002 | ORGANIC ANTI-REFLECTIVE COATING POLYMER, ANTI-REFLECTIVE COATING COMPOSITION COMPRISING THE SAME AND METHODS OF PREPARATION THEREOF | JUNG, JAE-CHANG |
| 10080507               | Not Issued | 041 | 02/22/2002 | CROSS-LINKING MONOMERS FOR PHOTORESIST, AND PROCESS FOR PREPARING PHOTORESIST POLYMERS USING THE SAME                               | JUNG, JAE CHANG |
| 10080335               | Not Issued | 094 | 02/21/2002 | MALEIMIDE-PHOTORESIST MONOMERS CONTAINING HALOGEN, POLYMERS THEREOF AND PHOTORESIST COMPOSITIONS COMPRISING THE SAME                | JUNG, JAE CHANG |
| 10079753               | 6586619    | 150 | 02/19/2002 | NOVEL PHOTORESIST   | JUNG, JAE       |

|          |            |     |            |   |                 |
|----------|------------|-----|------------|---|-----------------|
|          |            |     |            | MONOMER HAVING HYDROXY GROUP AND CARBOXY GROUP, COPOLYMER THEREOF AND PHOTORESIST COMPOSITION USING THE SAME                      | CHANG           |
| 10079348 | 6806025    | 150 | 02/20/2002 | PHOTORESIST MONOMERS, POLYMERS THEREOF AND PHOTORESIST COMPOSITONS CONTAINING THE SAME  | JUNG, JAE CHANG |
| 10053875 | 6501823    | 150 | 01/24/2002 | METHOD OF RECONSTRUCTING A TOMOGRAM OF AN X-RAY APPARATUS   | JUNG, JAE-HYUN  |
| 10037552 | Not Issued | 041 | 01/04/2002 | ORGANIC ANTI-REFLECTIVE COATING POLYMERS, ANTI-REFLECTIVE COATING COMPOSITION COMPRISING THE SAME AND PREPARATION METHODS THEREOF | JUNG, JAE-CHANG |
| 09630818 | 6416926    | 150 | 08/02/2000 | THIABICYCLO COMPOUND, A POLYMER-CONTAINING SAID COMPOUND, AND A PHOTORESIST MICRO PATTERN FORMING METHOD USING THE SAME           | JUNG, JAE CHANG |
| 09627627 | 6368771    | 150 | 07/28/2000 | NOVEL PHOTORESIST POLYMERS AND PHOTORESIST COMPOSITIONS CONTAINING THE SAME   | JUNG, JAE CHANG |
| 09621125 | 6368770    | 150 | 07/21/2000 | NOVEL PHOTORESIST MONOMERS, POLYMERS THEREOF, AND PHOTORESIST COMPOSITIONS CONTAINING THE SAME                                    | JUNG, JAE CHANG |
| 09621068 | 6448352    | 150 | 07/21/2000 | NOVEL PHOTORESIST MONOMER, POLYMER THEREOF AND PHOTORESIST COMPOSITION CONTAINING IT  | JUNG, JAE CHANG |
| 09605206 | 6808859    | 150 | 06/27/2000 | NOVEL ARF PHOTORESIST COPOLYMERS  | JUNG, JAE CHANG |
| 09595434 | 6399272    | 150 | 06/15/2000 | PHENYLENEDIAMINE DERIVATIVE-TYPE ADDITIVE USEFUL FOR A CHEMICALLY AMPLIFIED PHOTORESIST   | JUNG, JAE CHANG |
| 09593415 | 6379293    | 150 | 06/14/2000 | CENTRIFUGAL EXTRACTOR FOR ORGANIC PHASE USING A   | JUNG, JAE-HOO   |

| HEIGHT-ADJUSTABLE WEIR AND A DIVERT DISK |            |     |            |  |                 |
|--|------------|-----|------------|--|-----------------|
| 09582536                                 | 6485743    | 150 | 06/29/2000 | METHOD AND COMPOSITION OF AN ORAL PREPARATION OF ITRACONAZOLE  | JUNG, JAE-YOUNG |
| 09577097                                 | Not Issued | 161 | 05/24/2000 | TOP-COATING COMPOSITION FOR PHOTORESIST AND PROCESS FOR FORMING FINE PATTERN USING THE SAME            | JUNG, JAE CHANG |
| 09505241                                 | Not Issued | 161 | 02/16/2000 | PHOTORESIST COMPOSITION HAVING EXCELLENT RESISTANCE TO POST EXPOSURE DELAY EFFECT                      | JUNG, JAE CHANG |
| 09501096                                 | 6312868    | 150 | 02/09/2000 | NOVEL PHOTORESIST CROSS-LINKER AND PHOTORESIST COMPOSITION COMPRISING THE SAME                         | JUNG, JAE CHANG |
| 09499231                                 | 6322948    | 150 | 02/07/2000 | NOVEL PHOTORESIST CROSS-LINKER AND PHOTORESIST COMPOSITION COMPRISING THE SAME                         | JUNG, JAE CHANG |
| 09465426                                 | Not Issued | 161 | 12/21/1999 | METHOD FOR RETRIEVING AND DIALING PHONE NUMBER IN MOBILE TELEPHONE                                     | JUNG, JAE-IK    |
| 09465111                                 | Not Issued | 161 | 12/16/1999 | CROSS-LINKING MONOMERS FOR PHOTORESIST, AND PROCESS FOR PREPARING PHOTORESIST POLYMERS USING THE SAME  | JUNG, JAE CHANG |
| 09448964                                 | 6482565    | 150 | 11/24/1999 | PHOTORESIST CROSS-LINKER AND PHOTORESIST COMPOSITION COMPRISING THE SAME                               | JUNG, JAE CHANG |
| 09439206                                 | Not Issued | 041 | 11/12/1999 | METHOD FOR CONTROLLING TRANSMISSION CONTROL PROTOCOL WINDOW SIZE IN ASYNCHRONOUS TRANSFER MODE NETWORK | JUNG, JAE IL    |

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Day : Tuesday  
 Date: 10/26/2004

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# PALM INTRANET

## Inventor Name Search Result

Your Search was:

Last Name = JUNG

First Name = WOOK

| Application# | Patent#    | Status | Date Filed | Title                            | Inventor Name 4 |
|--------------|------------|--------|------------|----------------------------------|-----------------|
| 29196103     | Not Issued | 030    | 12/23/2003 | ELECTRIC PRESSURE RICE COOKER    | JUNG, WOOK JUN  |
| 29175786     | D489223    | 150    | 02/11/2003 | ELECTRICAL PRESSURE COOKER       | JUNG, WOOK JUN  |
| 29174120     | D479431    | 150    | 01/13/2003 | MICROWAVE OVEN WITH COFFEE-MAKER | JUNG, WOOK JUN  |
| 29174119     | D479782    | 150    | 01/13/2003 | MICROWAVE OVEN WITH TOASTER      | JUNG, WOOK JUN  |

Inventor Search Completed: No Records to Display.

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|----------|------|-----------------------------|---|------------------|
| 1        | 0    | dawer adj lock              | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/26 06:38 |
| 2        | 464  | drawer adj lock             | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/26 06:38 |
| 3        | 2    | drawer adj lock same snap   | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/26 06:40 |
| 4        | 6155 | snap adj lock               | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/26 06:40 |
| 5        | 86   | snap adj lock and drawer    | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/26 06:53 |
| 6        | 27   | sliding adj lock and drawer | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/26 07:01 |
| 7        | 100  | slid\$3 adj lock and drawer | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/26 07:01 |
| 8        | 100  | slid\$3 adj lock and drawer | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/26 07:12 |
| -        | 15   | "566246"                    | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25 14:45 |
| -        | 8    | "5662246"                   | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/09/30 14:33 |
| -        | 8    | "6003738"                   | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/09/30 14:35 |
| -        | 2    | "6543649"                   | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/09/30 14:35 |
| -        | 7    | "6186366"                   | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/09/30 14:37 |
| -        | 14   | "5482186"                   | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/09/30 14:38 |

|   |      |   |   |                     |
|---|------|---|---|---------------------|
| - | 2    | "6158624"                                     | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/09/30<br>14:39 |
| - | 16   | "5040702"                                     | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/09/30<br>16:24 |
| - | 1369 | refrigerator with dispense\$3                 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>14:47 |
| - | 382  | refrigerator with dispense\$3 same door       | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>15:05 |
| - | 1801 | drain with lock                               | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>15:05 |
| - | 17   | drain with lock same dispense\$3              | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>15:22 |
| - | 30   | drain with lock\$3 same dispense\$3           | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>15:29 |
| - | 4    | (drain adj pan) with lock\$3 same dispense\$3 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>15:33 |
| - | 24   | (drain adj pan) with lock\$3                  | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>16:02 |
| - | 1003 | 62/285  | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>16:03 |
| - | 22   | 62/285 and lock                               | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>16:04 |
| - | 10   | 62/288 and lock                               | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>16:05 |
| - | 11   | 62/291 and lock                               | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>16:05 |
| - | 11   | (drain adj pan) with lock                     | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/10/25<br>16:07 |

|   |       |                                     |   |                     |
|---|-------|-------------------------------------|---|---------------------|
| - | 0     | condensate adj pan with lock        | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/10/25<br>16:08 |
| - | 8     | condensate adj drain with lock      | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/10/25<br>16:25 |
| - | 13645 | snap with lock                      | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/10/25<br>16:25 |
| - | 14    | snap with lock same pan             | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/10/25<br>16:30 |
| - | 35    | groove with lock same pan           | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/10/25<br>16:31 |
| - | 1078  | groove with lock same hook          | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/10/25<br>16:31 |
| - | 0     | groove with lock same hook same pan | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/10/25<br>16:31 |
| - | 12    | groove with lock same hook and pan  | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/10/25<br>16:33 |
| - | 841   | pan with lock                       | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/10/25<br>16:33 |
| - | 28    | pan with lock same groove           | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/10/25<br>16:40 |